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MANNAVA & KANG, P.C.

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P. 001/019

PATENT

Atty Docket No.: 10004808-1

In The U.S. Patent and Trademark Office

In Re the Application of:

Inventor(s): Osamu S. Nakagawa **Confirmation No.:** 3635

Serial No.: 09/891,324 **Examiner:** Schillinger, Laura M.

Filed: June 27, 2001 **Group Art Unit:** 2813

Title: PROCESS FOR HIGH-DIELECTRIC CONSTANT METAL-INSULATOR
METAL CAPACITOR IN VLSI MULTI-LEVEL METALIZATION SYSTEMS

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF FACSIMILE TO THE USPTO

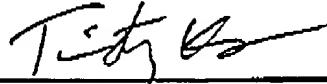
I hereby certify that this correspondence is being transmitted to the Patent and Trademark Office facsimile number (703) 872-9306 on May 6, 2005. This correspondence contains the following document(s):

1 sheet of Transmittal Letter for Response/Amendment. (2 copies).

16 sheets of Request for Reconsideration.

Respectfully submitted,

MANNAVA & KANG, P.C.



Timothy B. Kang
Reg. No.: 46,423

On May 6, 2005

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P. 002/019

PATENT APPLICATION
ATTORNEY DOCKET NO. 10004808-1

IN THE
UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Osamu S. Nakagawa Confirmation No.: 3635
Application No.: 09/891,324 Examiner: Schillinger, Laura
Filing Date: June 27, 2001 Group Art Unit: 2813
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IN VLSI MULTI-LEVEL METALIZATION SYSTEMS

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Commissioner For Patents
PO Box 1450
Alexandria, VA 22313-1450

TRANSMITTAL LETTER FOR RESPONSE/AMENDMENT

Sir:

Transmitted herewith is/are the following in the above-identified application:

(X) Response/Amendment () Petition to extend time to respond
() New fee as calculated below () Supplemental Declaration
(X) No additional fee
() Other: _____ (fee \$ _____)

CLAIMS AS AMENDED BY OTHER THAN A SMALL ENTITY						
(1) FOR	(2) CLAIMS REMAINING AFTER AMENDMENT	(3) NUMBER EXTRA	(4) HIGHEST NUMBER PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	(6) RATE	(7) ADDITIONAL FEES
TOTAL CLAIMS	13	MINUS	20	= 0	X \$50	\$ 0
INDEP. CLAIMS	1	MINUS	3	= 0	X \$200	\$ 0
[] FIRST PRESENTATION OF A MULTIPLE DEPENDENT CLAIM					+ \$360	\$ 0
EXTENSION FEE	1ST MONTH \$120.00	2ND MONTH \$450.00	3RD MONTH \$1020.00	4TH MONTH \$1590.00		\$ 0
OTHER FEES						\$
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$ 0

Charge \$ 0 to Deposit Account 08-2025. At any time during the pendency of this application, please charge any fees required or credit any overpayment to Deposit Account 08-2025 pursuant to 37 CFR 1.25. Additionally please charge any fees to Deposit Account 08-2025 under 37 CFR 1.16, 1.17, 1.19, 1.20 and 1.21. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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number (703) 872-9306 on May 6, 2005
Number of pages: 19

Osamu S. Nakagawa

By Tsuyoshi

Typed Name: Judy H. Chung

Timothy B. Kang

Signature: Judy H. Chung

Attorney/Agent for Applicant(s)
Reg. No. 46,423

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(FAX) 703 880 5270 P. 003/019
PATENT APPLICATION
ATTORNEY DOCKET NO. 10004808-1

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UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Osamu S. Nakagawa

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Number of pages: 19

Typed Name: Judy H. Chung

Signature: Judy H. Chung

Osamu S. Nakagawa

By Tony B. Kang

Timothy B. Kang

Attorney/Agent for Applicant(s)
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Date: May 6, 2005

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REQUEST FOR RECONSIDERATION

Sir:

Applicant respectfully submits this Request for Reconsideration in response to the Final Official Action mailed on March 8, 2005. Please find below a listing of all the pending claims for the convenience of the Examiner in considering this Request for Reconsideration. The Examiner is respectfully requested to consider the remarks following the listing of the pending claims.